

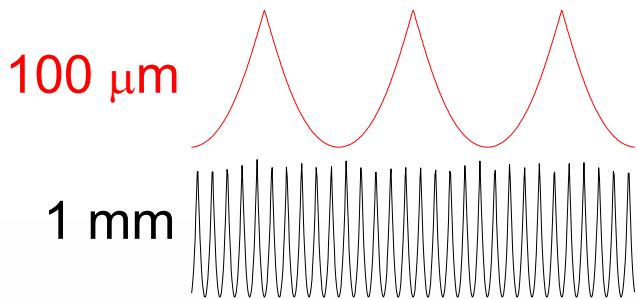
Quantum Cascade Micro-Lasers with Two-dimensional Photonic Crystal Reflectors

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- Introduction
- Design and Fabrication
- Results and Discussion
- Summary



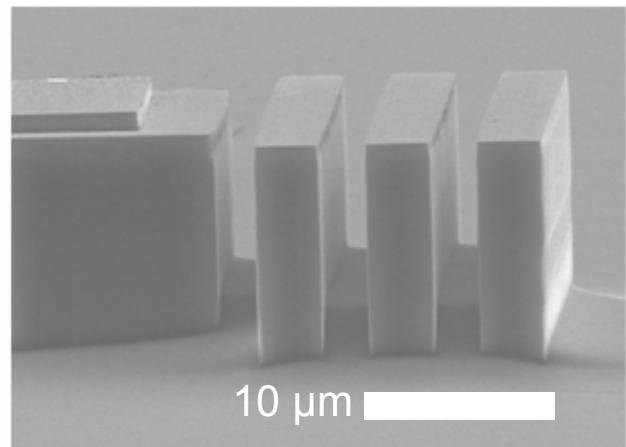
Single-mode: reduction of resonator length
→ increased mode spacing
→ increased mirror losses



→ Highly reflective mirrors required

2D PhCs: Colombelli et al., Science 302,
pp. 1374, 2003

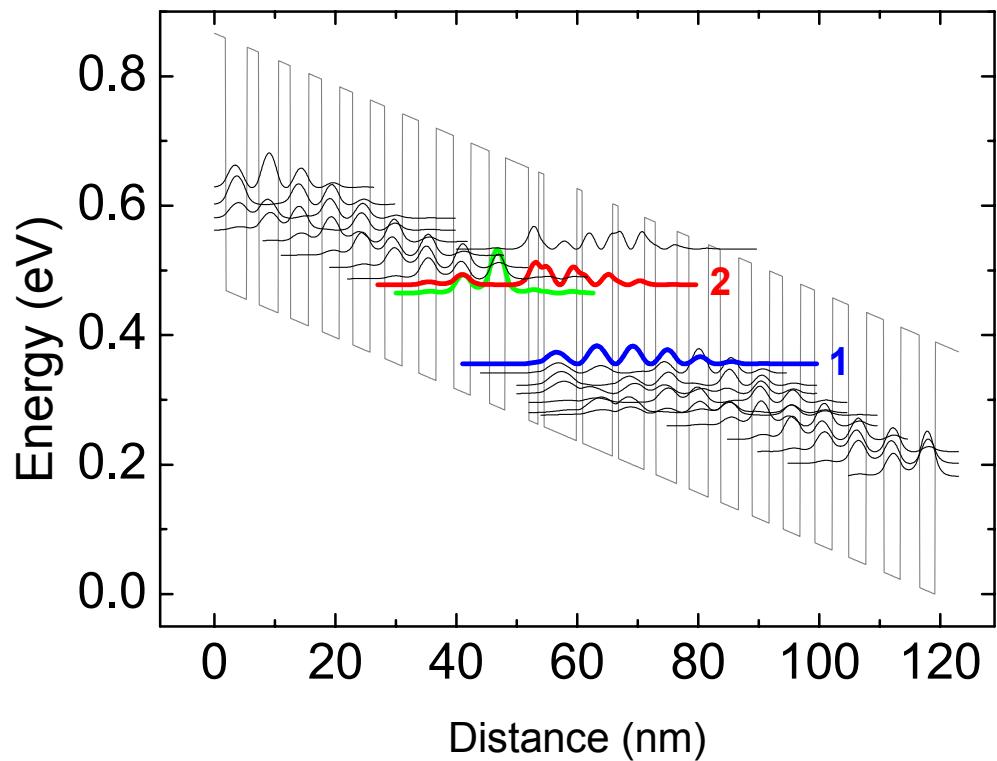
Dunbar et al., Opt. Exp. 13,
no. 13, pp. 8960, 2005



Bound-to-continuum
 $\text{GaAs}/\text{Al}_{0.45}\text{Ga}_{0.55}\text{As}$
active region design

Pflügl et al. Appl. Phys.
Lett. 83(23) (2003)

- Resonant tunneling between **lowest injector state** and **upper laser level 2**
- Fast depopulation of **lower laser level 1** by interminiband scattering processes

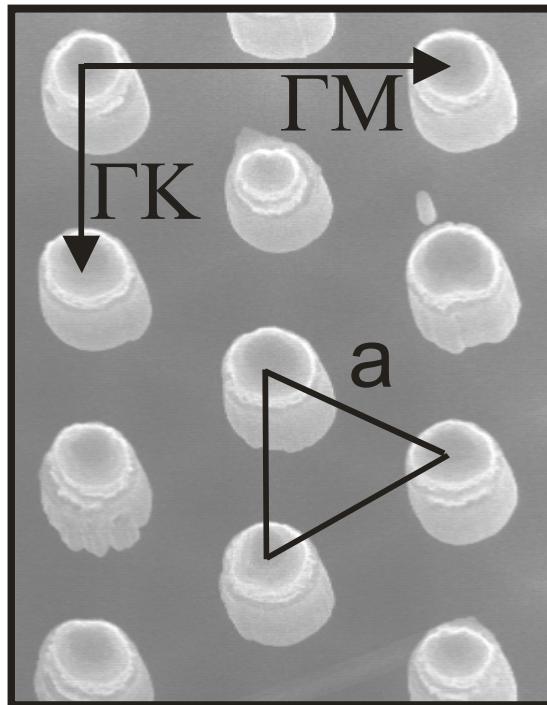


Trigonal PhC lattice with high index pillars used as reflector

Lattice constant $a = 3.5 \mu\text{m}$

Pillar diameter $d = 1.7 \mu\text{m}$

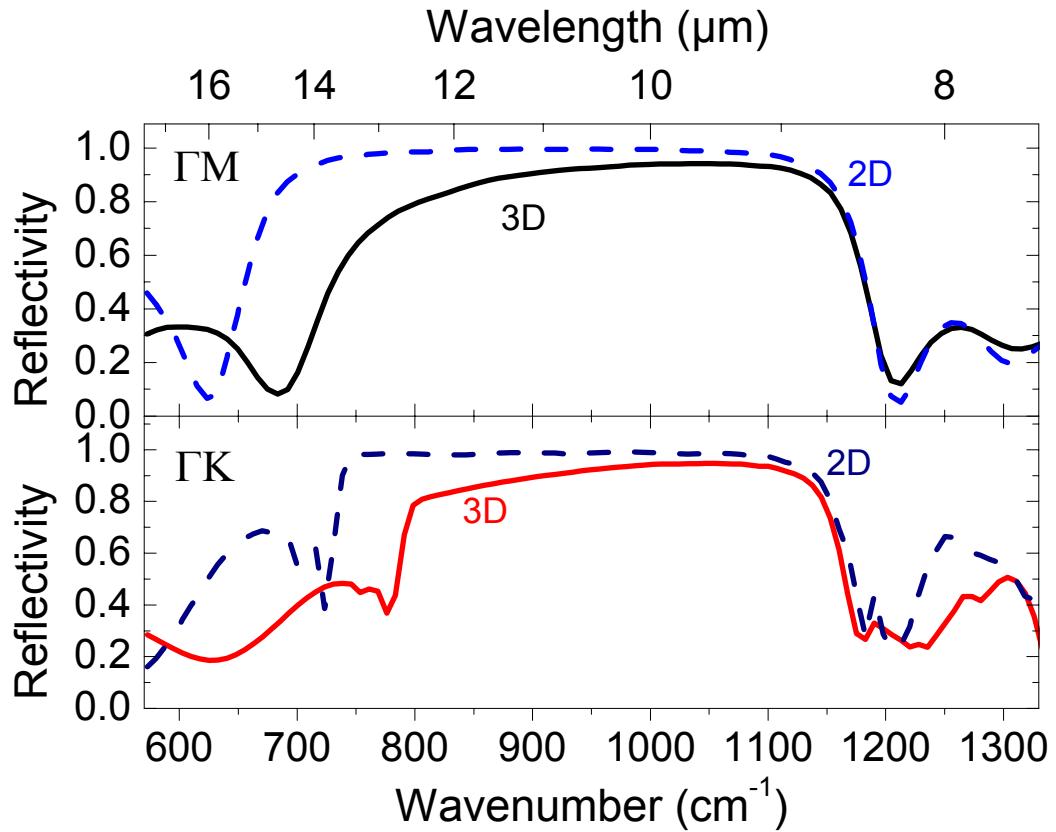
→ Photonic band gap at
the emission
wavelength ($\sim 11 \mu\text{m}$)



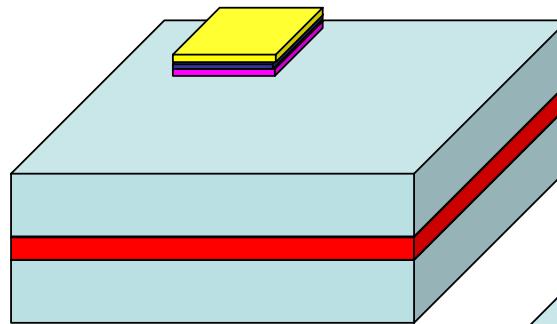
Reflectivity Calculations

FDTD simulations
for 1.5 period
(3 column rows)

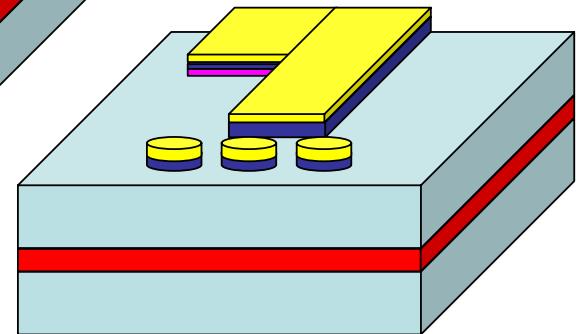
- Broad stop band
- Diffraction losses limit max. reflectivity
- > 80 % reflectivity (3D)



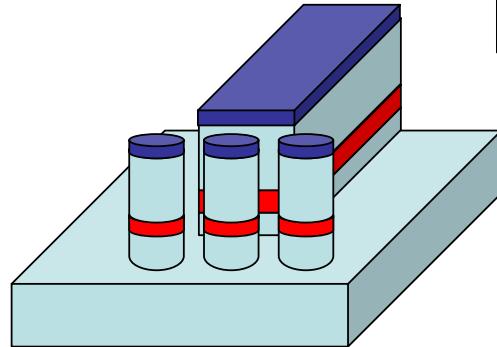
(1) Definition of contact pad
(optical lithography + lift-off)



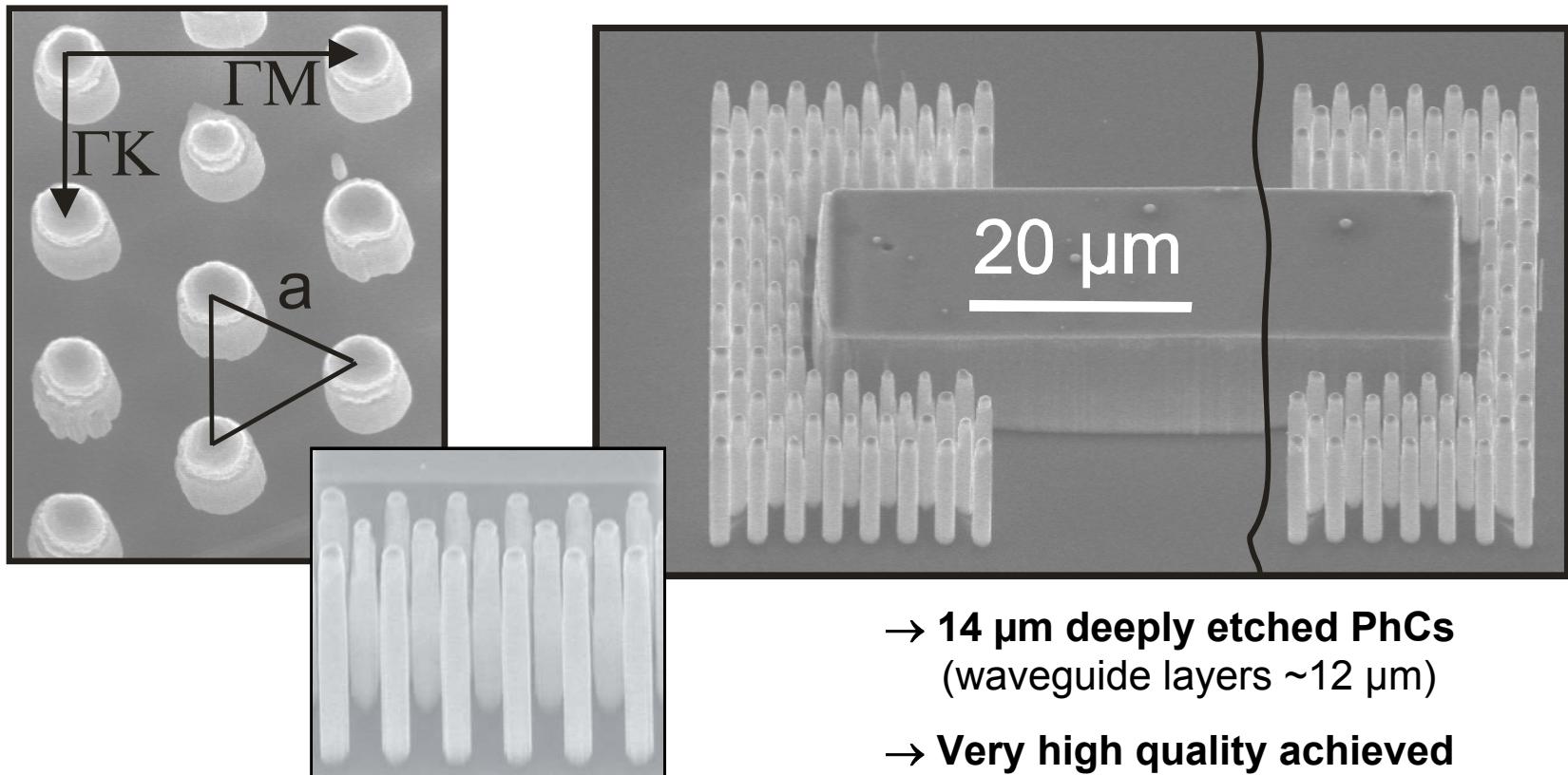
(2) RWG and PhC mirror definition
(e-beam lithography + lift-off)



(3) Pattern transfer
(dry etching by ECR-RIE)



→ **Fabrication in
single etch step**

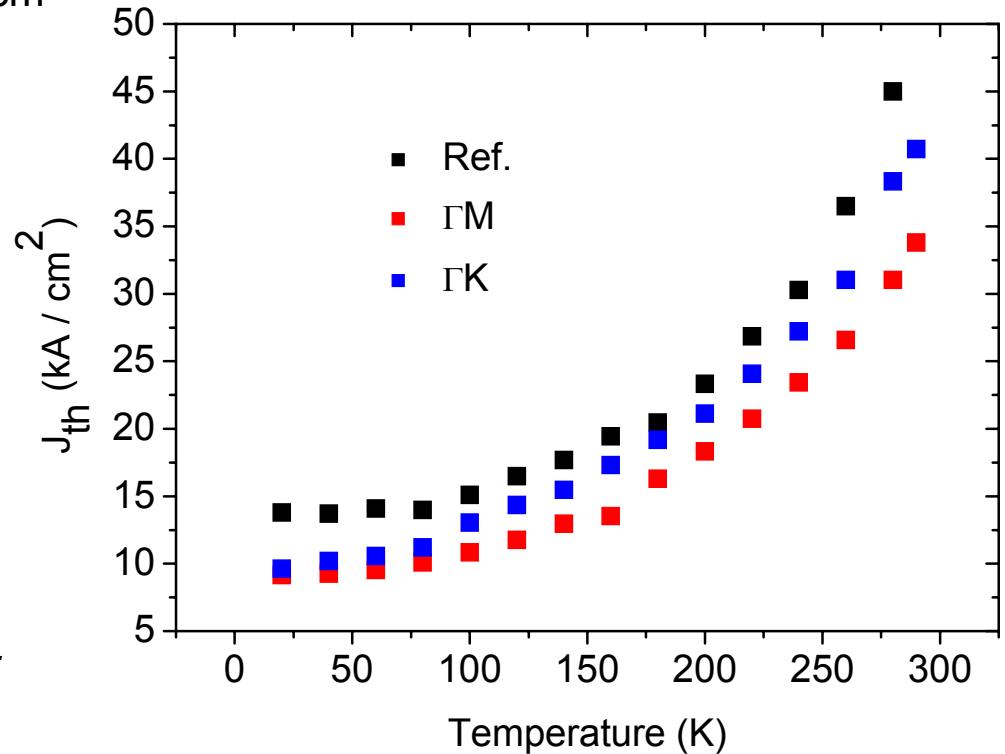


1 mm (cleaved) $\alpha_m = 13.1 \text{ cm}^{-1}$
600 μm PhCs $\alpha_m = 1.4 \text{ cm}^{-1}$

600 μm PhC QCLs show reduced thresholds

ΓM : 34 % @ 20 K
 ΓK : 30 % @ 20 K
theo. estim.: 38 %

S. Höfling et al. , *Appl. Phys. Lett.* 89, 191113, 2006.



Mode spacing:

- 2.47 cm^{-1} (600 μm PhC)
- 1.50 cm^{-1} (1 mm Ref.)

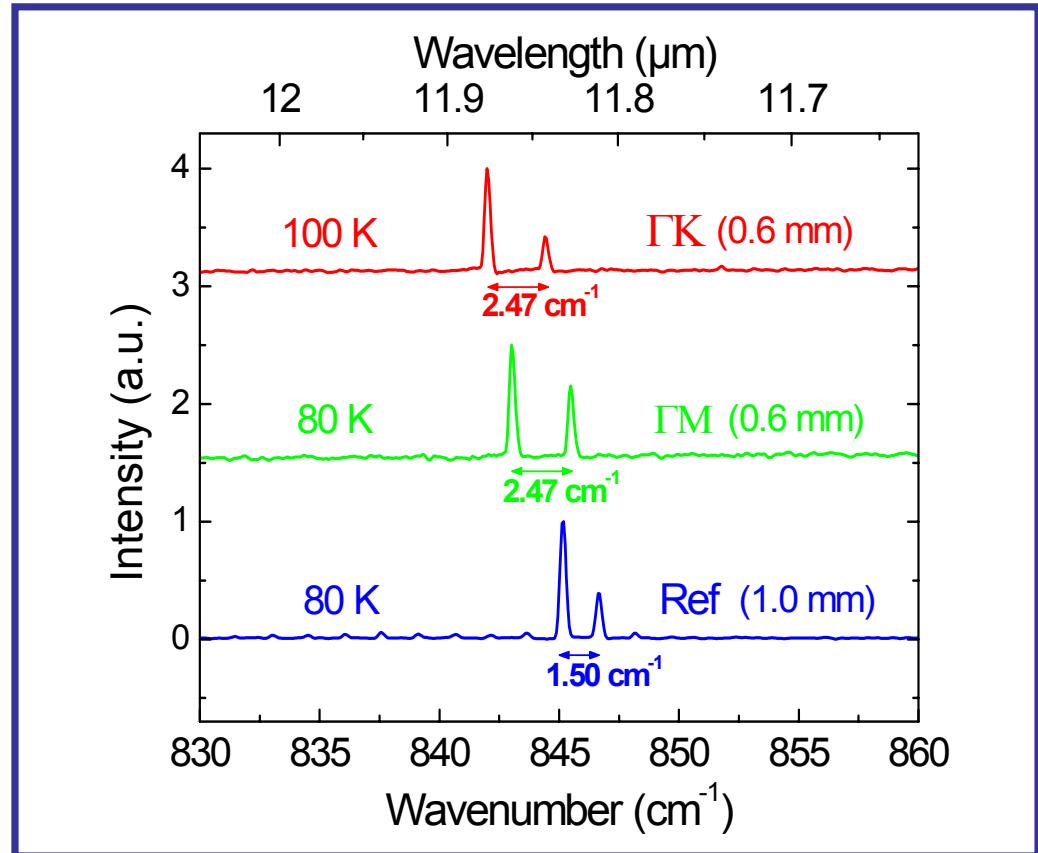
$$\rightarrow n_{\text{eff}} = 3.35$$

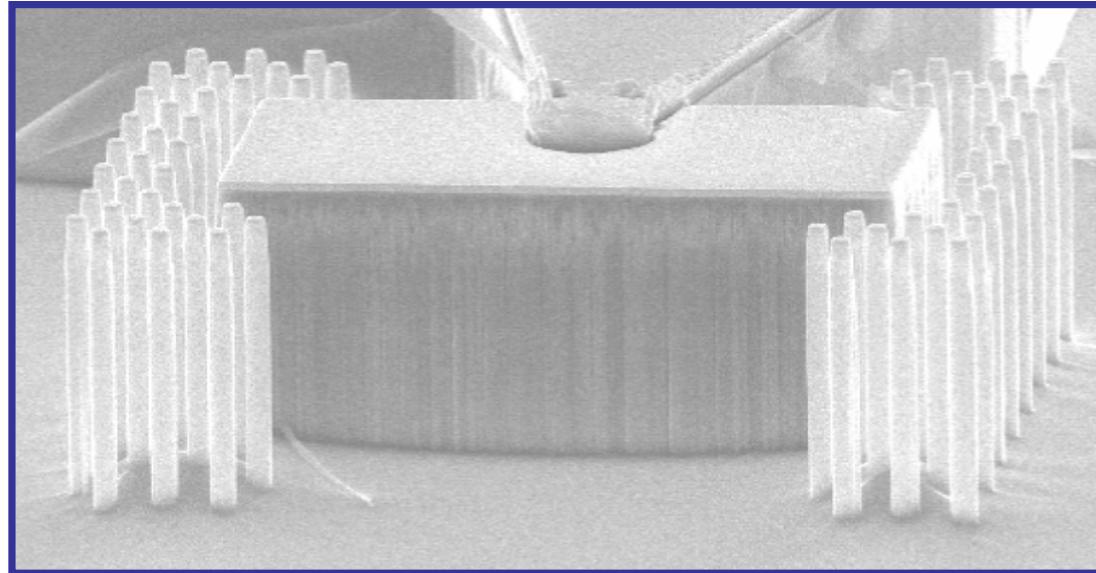
Spontaneous emission:

FWHM 32 cm^{-1}

$$\Delta\nu \sim 15 \text{ cm}^{-1}$$

$$\rightarrow L_{\text{res}} \sim 100 \text{ } \mu\text{m}$$





1 mm (cleaved) $\alpha_m = 13.1 \text{ cm}^{-1}$

100 μm PhCs $\alpha_m = 16.3 \text{ cm}^{-1}$

Accepted for PTL

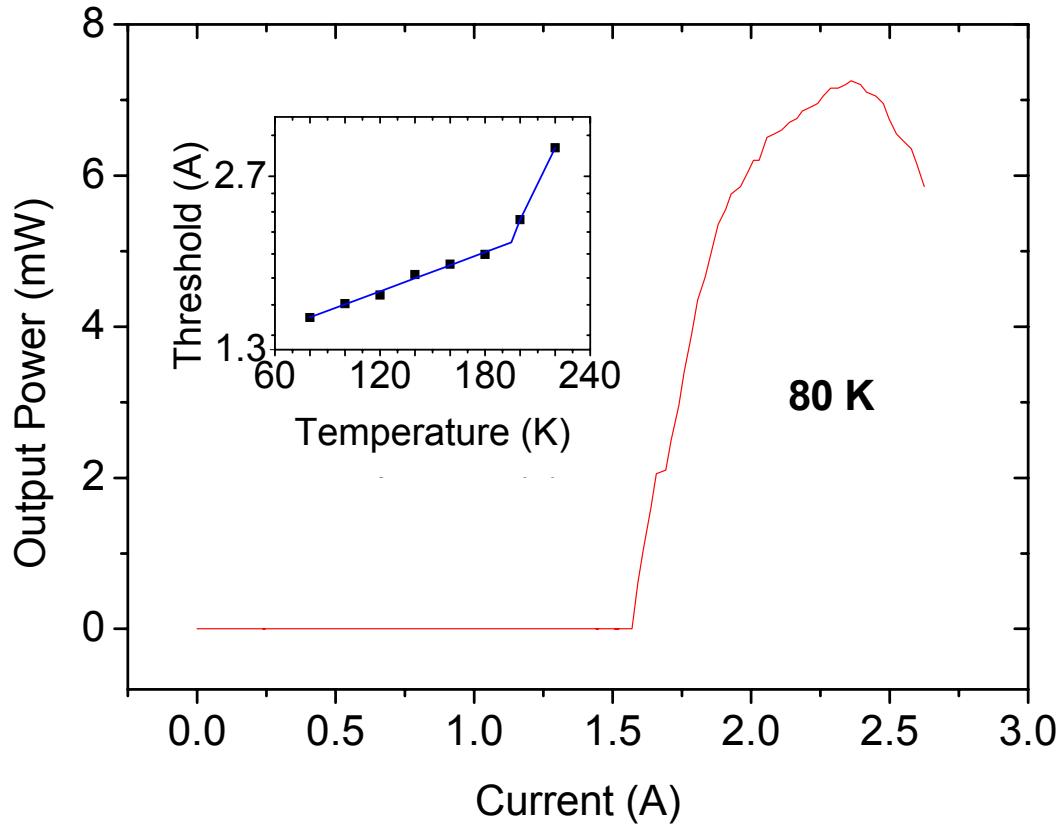
$\rightarrow \alpha_m \sim \text{constant}$

80 K

- $I_{th} = 1.6 \text{ A}$
- $I_{sat} = 2.4 \text{ A}$
- $P_{max} = 7.3 \text{ mW}$

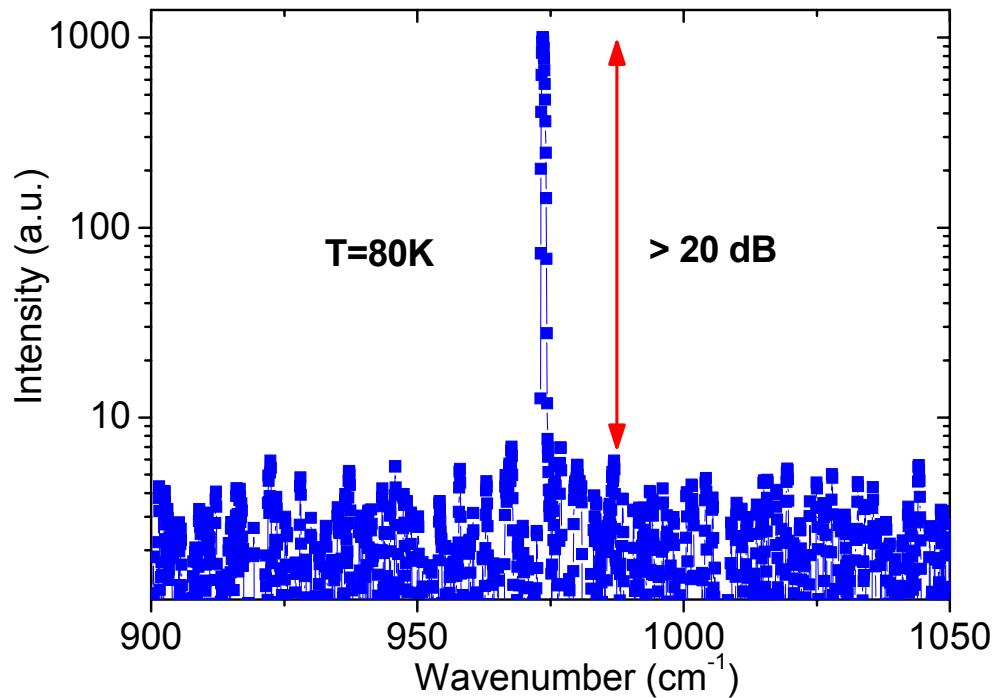
Performance limited due to

- High reflectivity of PhCs
- Current leakage
- Increased thermal resistance

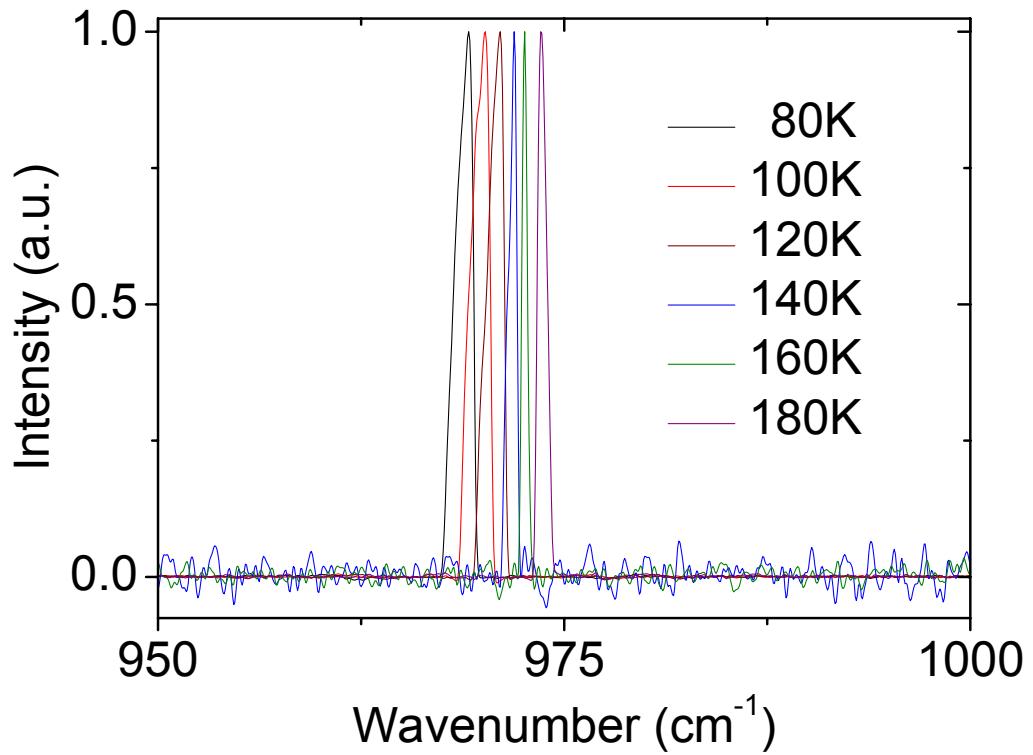


Single-mode operation (1)

- Limited gain bandwidth
 - Large mode spacing
- Only one mode excited



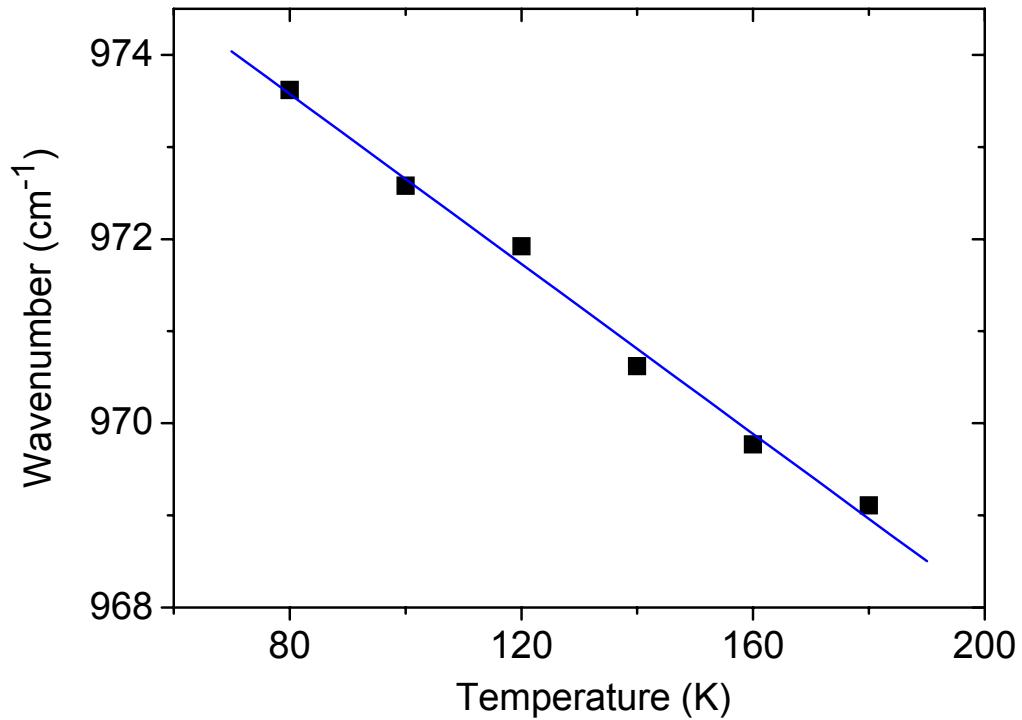
Stable single-mode
emission up to $T = 180$ K



Stable single-mode emission
up to 180 K

→ enables single-mode tuning
with temperature

Tuning rate of $-0.046 \text{ cm}^{-1} / \text{K}$



- Fabrication of high quality PhCs with large etch depths ($> 14 \mu\text{m}$)
- 30% reduction of threshold current (20K) with 600 μm long devices
- 100 μm long micro-lasers: stable single-mode operation up to 180K
- Transfer to InP-based QCLs: possibility of room-temperature operation of PhC microlasers

Acknowledgement: M. Emmerling and A. Wolf